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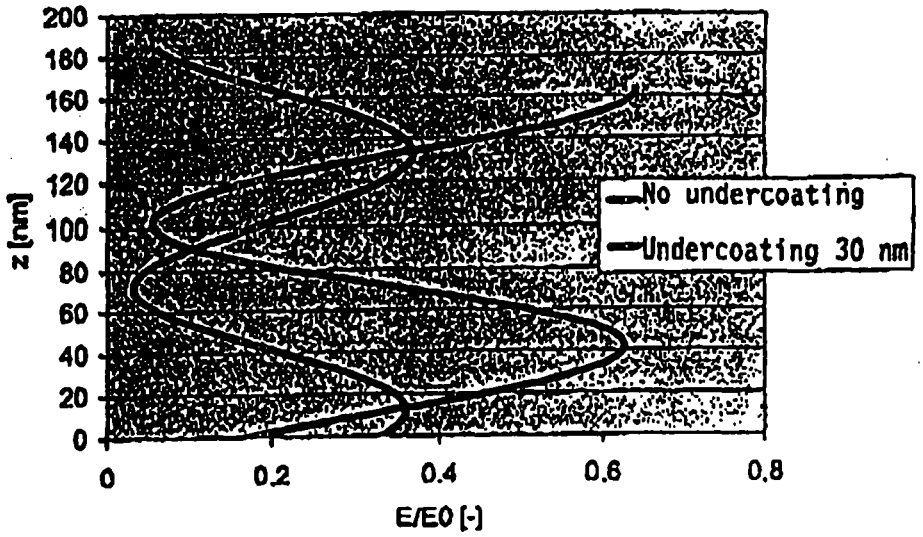
(54) Title: A METHOD FOR MANUFACTURING A SUBSTRATE FOR USE IN A STAMPER MANUFACTURING PROCESS, AS WELL AS A SUBSTRATE OBTAINED BY USING SUCH A METHOD



(57) Abstract: The present invention relates to a method for manufacturing a substrate for use in a stamper manufacturing process. The present invention furthermore relates to a substrate which is used in a stamper manufacturing process and to a method for manufacturing a stamper to be used in producing optical discs, comprising the exposing, developing and heating of a photosensitive film that has been coated onto a substrate.

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